



In re the Application of

Tomoko OHTSUKI Group Art Unit: 2828

Application No.: 10/070,684 Examiner: L. Scott, Jr.

Filed: September 12, 2002 Docket No.: 112162

For: LASER DEVICE AND EXPOSURE METHOD

## **STATUS REQUEST**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowance dated April 15, 2004, Applicant filed a Request for Continued Examination (RCE), an Amendment, an Amendment Transmittal and an Information Disclosure Statement on July 14, 2004. Applicant has not received any further communications from the Patent Office in response to the July 14 RCE, Amendment and Information Disclosure Statement.

The Patent Office is requested to act on the July 14 RCE, Amendment and Information Disclosure Statement. The Examiner is invited to contact Applicant's undersigned attorney at the telephone number listed below if there are any questions.

Respectfully submitted,

Mario A. Costantino Registration No. 33,565

MAC/ccs

Date: January 14, 2005

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